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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of : Attorney Docket No. 2006_0622A
Masahiko SEKIMOTO et al. : **Confirmation No. 4763**
Serial No. 10/578,100 : Group Art Unit 1792
Filed May 3, 2006 : Examiner Brenda A. Lamb
SUBSTRATE HOLDING APPARATUS, :
SUBSTRATE HOLDING METHOD, AND
SUBSTRATE PROCESSING APPARATUS

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

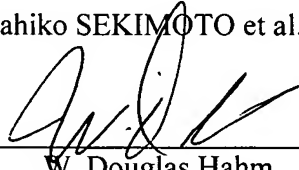
Pursuant to the requirement set forth in the Office Action mailed December 30, 2009,
Applicants hereby elect invention II, claims 11-14, 18, 20, and 21.

In view of this election, a full examination on the merits of the present application is
respectfully requested.

Respectfully submitted,

Masahiko SEKIMOTO et al.

By


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